

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/565,767 Confirmation No. 2990  
Applicant : Yuichiro Shindo  
371 Filed : January 24, 2006  
Art Unit : 1793  
Examiner : Mark L. Shevin  
Customer No. : 00270  
Title : HIGHLY PURE HAFNIUM MATERIAL, TARGET AND THIN  
FILM COMPRISING THE SAME, AND METHOD FOR  
PRODUCING HIGHLY PURE HAFNIUM

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

Sir:

This is a Response being submitted with a Request for Continued Examination (RCE) in reply to a FINAL Office Action dated November 20, 2009. A Petition for a Two Month Extension of Time is filed herewith to extend the deadline for response from February 20, 2010 to April 20, 2010.

**Remarks/Arguments** begin on page 2 of this paper.